



PATENT APPLICATION

Election
#17/C
4/26/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Eiji NATORI

Group Art Unit: 2822

Application No.: 09/819,687

Examiner: M. F. Guerrero

Filed: March 29, 2001

Docket No.: 109121

For: METHOD AND DEVICE FOR MANUFACTURING CERAMICS,
SEMICONDUCTOR DEVICE, AND PIEZOELECTRIC DEVICE

AMENDMENT AND
RESPONSE TO ELECTION OF SPECIES REQUIREMENT

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

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APR 25 2003
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In response to the Election of Species Requirement mailed on March 25, 2003, Applicant hereby elects Species III, a method of selectively forming a ceramic film and crystallizing the film using an electromagnetic wave. Applicant asserts that claims 23-34 read on the elected species. In addition, Applicant asserts that claim 23 is generic to all species. The election is made with traverse. Please amend the above-identified application as follows:

IN THE CLAIMS:

Please cancel claims 41-49 without prejudice to or disclaimer of the subject matter contained therein.

Please replace claims 35, 37, 39 and 40 as follows:

35. (Twice Amended) The method of fabricating ceramics as defined in claim 23, wherein at least one of the active species and the electromagnetic wave is fed to part of a substrate.

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